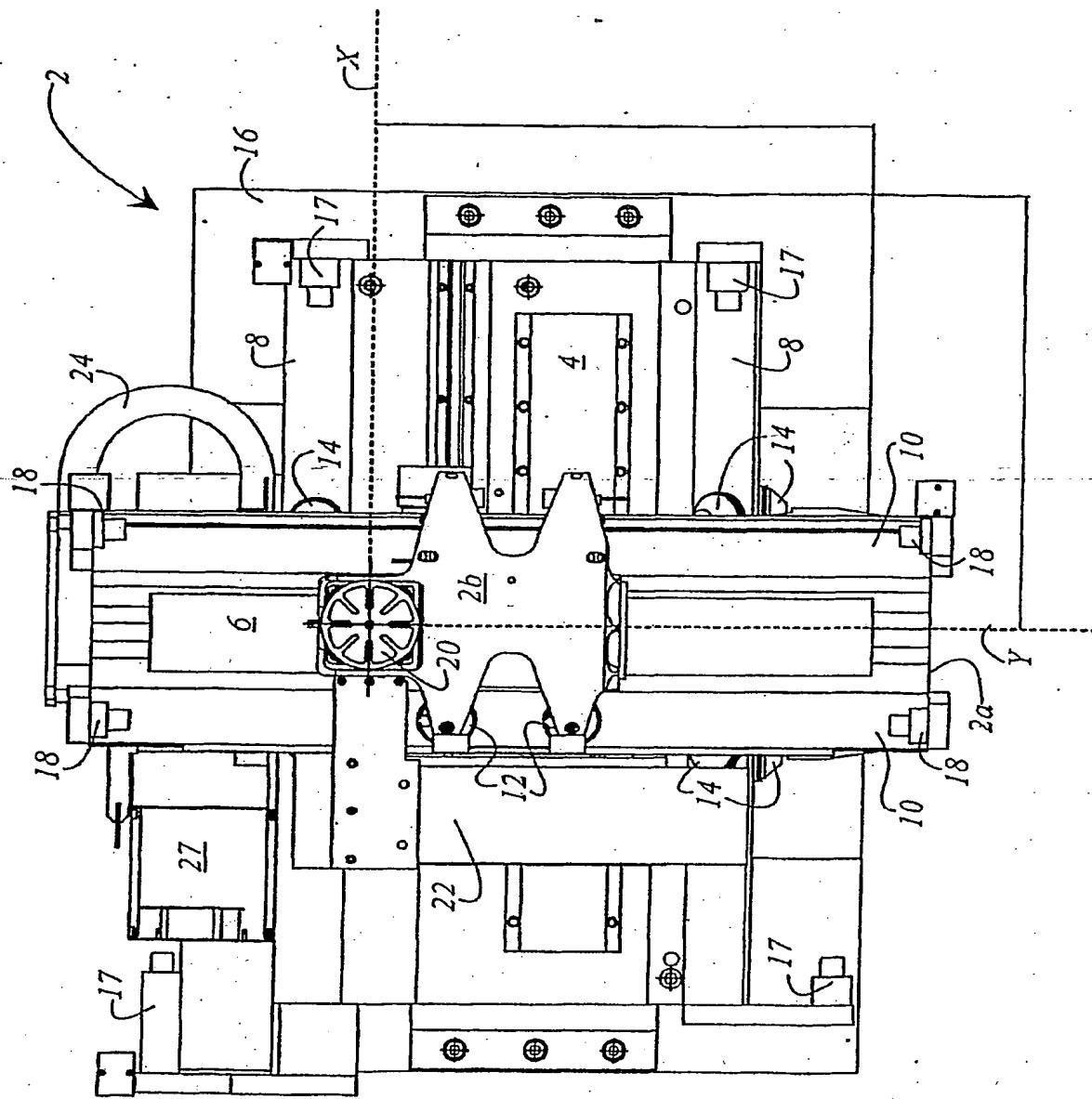


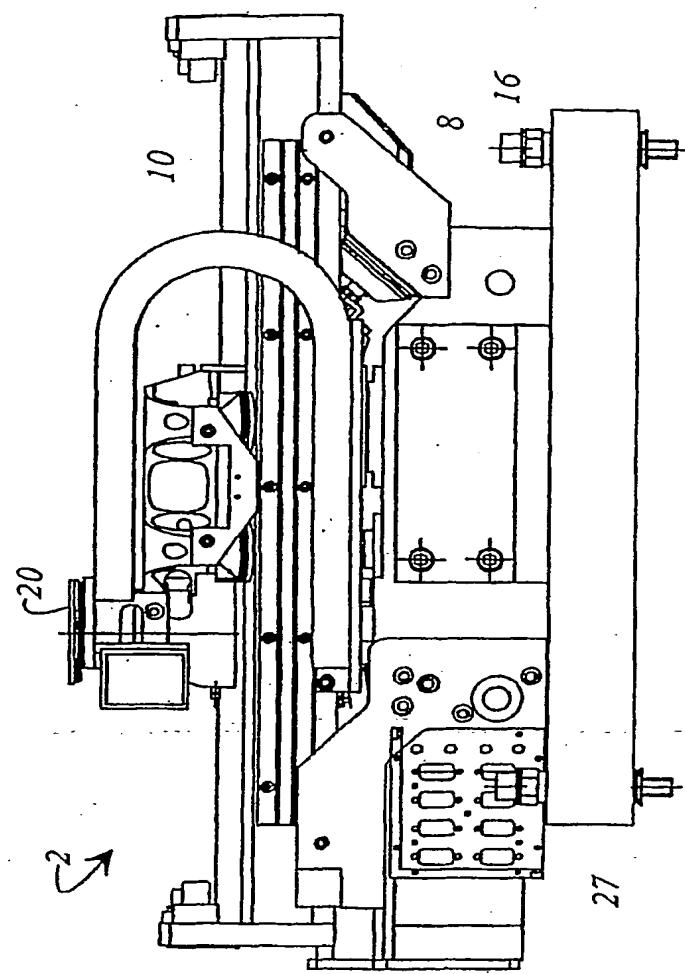
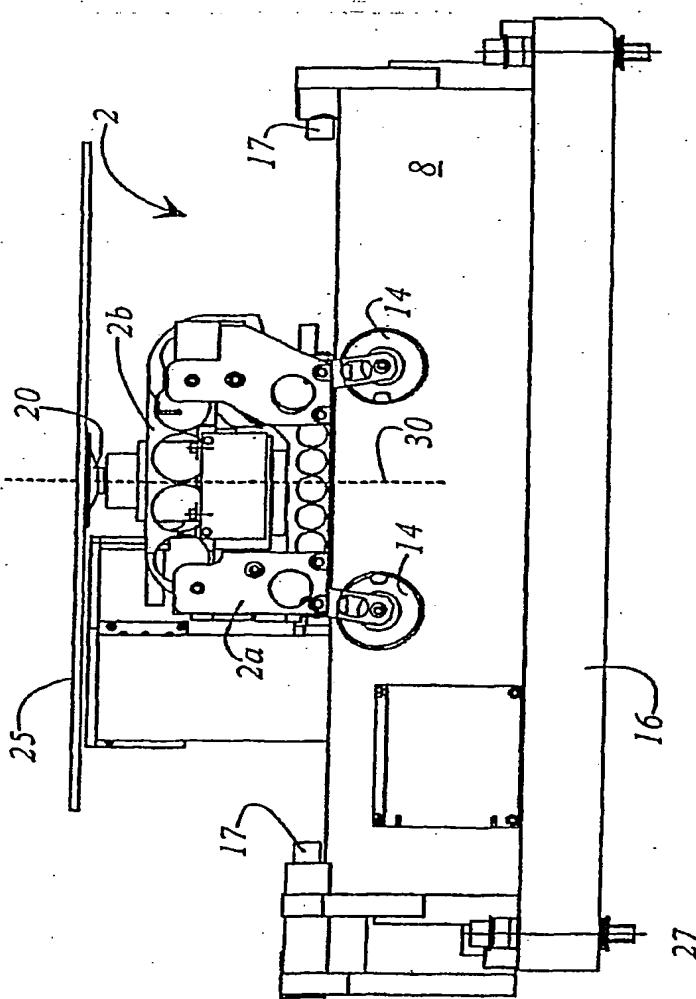


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Fig. 1





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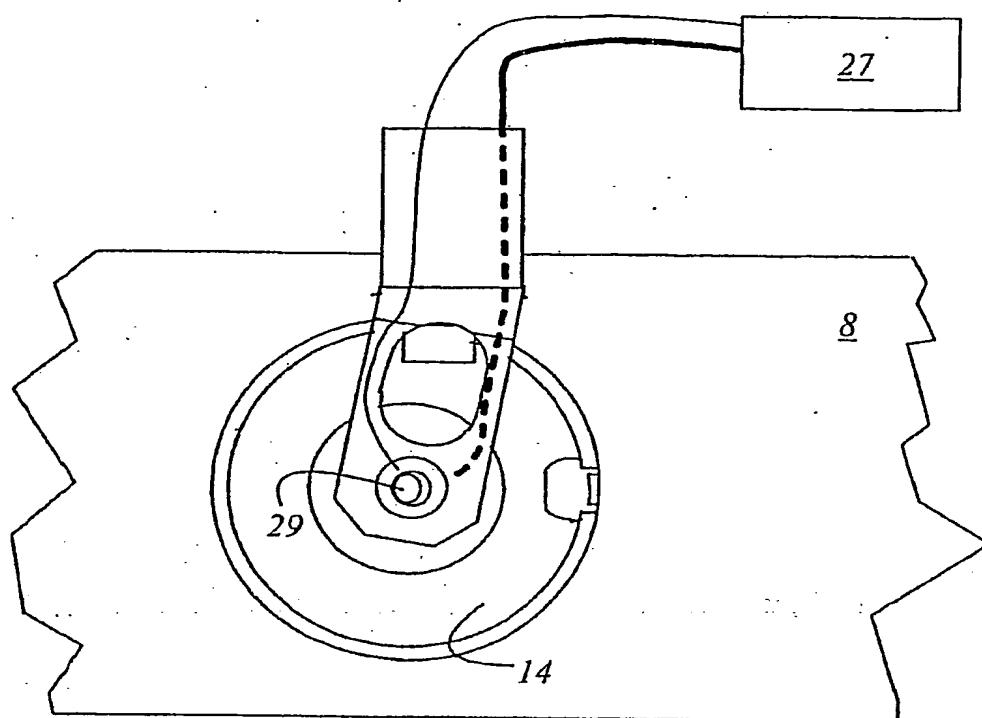


Fig. 4a

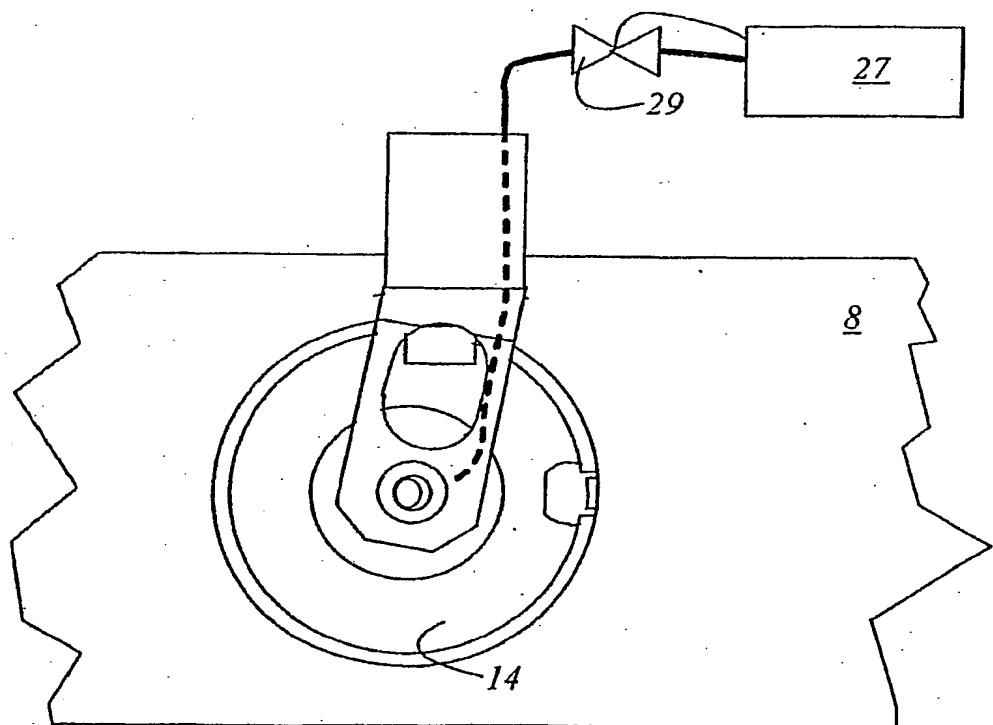


Fig. 4b

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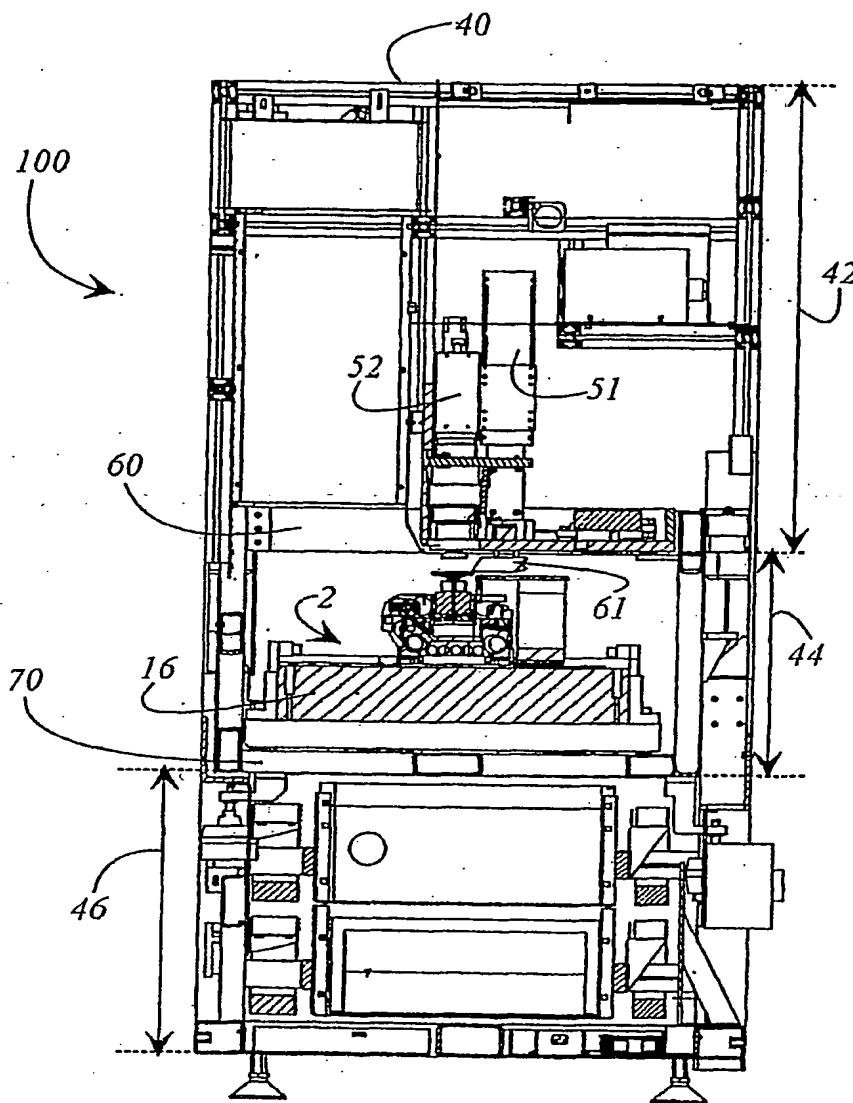


Fig. 5